

## 2017 Principal Investigators Meeting

Professor Ming C. Wu

**Faculty Director** 

**Dr. Bill Flounders** 

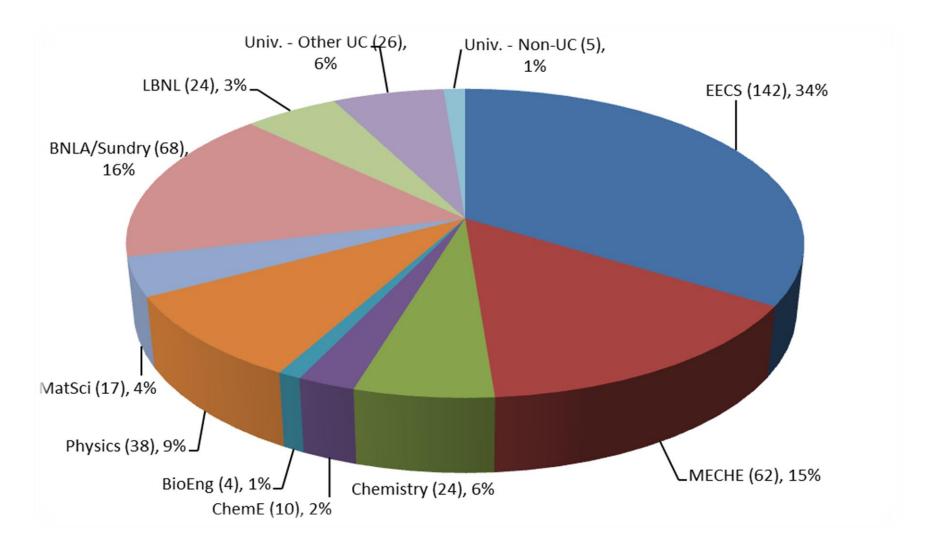
**Executive Director** 





- Membership Status, Usage UCB Dept Trends
- Web Page Highlights
- New Equipment / Capabilities
- ✤ FY 16/17 Rates Overview
- Summary of Support from VCR's Office

### Lab Members by Department FY 16 Total = 420 Membership is strong and stable



#### Annual PI Meeting

#### <sup>3</sup> May 5, 2017

## The NanoLab 2016 Highlights of the Top 20

Top 20 by Department		Financ	Financial		
EECS	11	All Academic	\$2.28 M total		
Mech Eng	3	Top 20 Academic	\$1.86 M total		
Chemistry	2	All BNLA	\$1.66 M total		
Physics	2				
MSE	1	Top 10 Academic	> \$75K each		
UC Davis EE	1	Тор 10-20	> \$30K each		

### Lab Members Historical Analysis

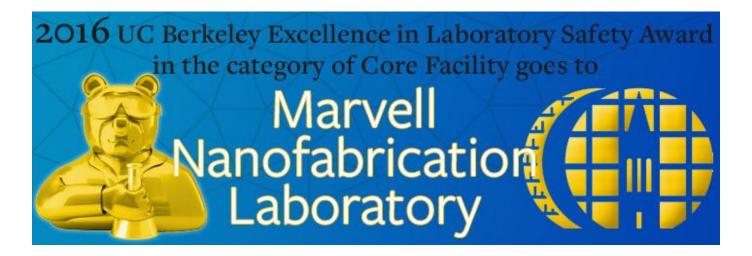
Fiscal Year	2010	2011	2012	2013	2014	2015	2016
Total	466	474	497	471	462	441	420
UCB	367	353	370	340	326	280	297
Ext Academic	48	67	68	59	66	87	55
BNLA	51	54	59	72	70	74	68
EECS	122	132	138	126	139	135	142
Physics	42	36	45	39	35	31	38
MSE	21	27	31	23	21	23	17
Mech Eng	102	99	106	95	87	59	62
BioEng	12	10	7	8	4	4	4
Chem/ChemE	65	47	42	49	30	28	34

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### NanoLab Awarded EH&S Safety Recognition







### New NanoLab Website Highlights

### New (last year) 2min NanoLab Video On the home page or at news and events https://www.youtube.com/embed/EwfChuacUCg

- NanoLab Awarded EH&S 2016 Core Facility Excellence in Laboratory Safety Award
- Evap Class Now On Line Video

https://drive.google.com/file/d/0Bwt\_-WcNo6O-T041ZmROWUFEUG8/view

- Etch Class On Line Video Coming Soon
- On Line Process Specifications Modeled on TDSI Process Specification Charts

https://nanolab.berkeley.edu/public/manuals/process\_specifications.shtml

# New ebeam writer installed Delivery: Nov28, 2016 Released: Dec 20, 2016

CABL-UH130 UH110 (110 kV), UH90 (90 kV)

Vacc: 130 kV Max (25-130 kV, 5 kV steps)

- Single-Stage Acceleration Electron Gun up to 130 kV
- Micro-Discharge Free Electron Optical Column
- Beam Diameter: < 1.6 nm</p>
- Fine Line: < 7 nm</p>
- Ultra-stable write capability with dual thermal controller
- Pattern Generator: 100MHz

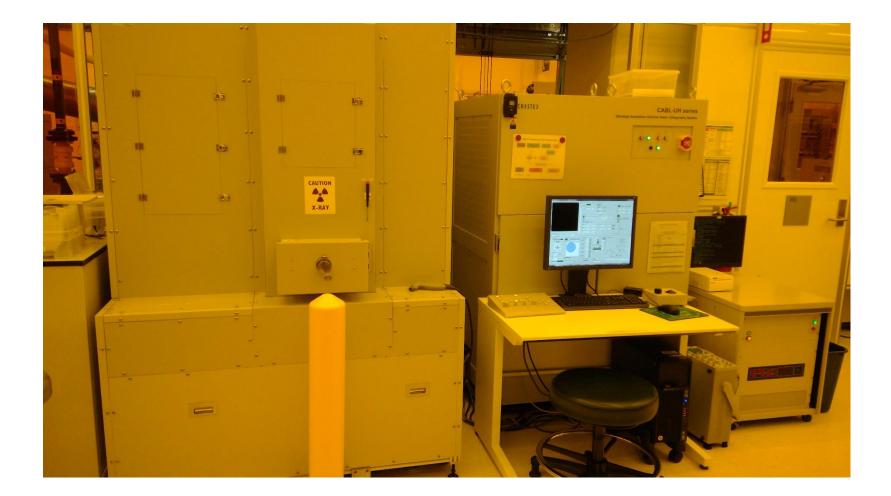
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THANK YOU ! CRESTED



# Crestec130kv In The NanoLab Includes Beamer Proximity Effect Correction SW



## New PR Coat and Develop System Thank you TEL



TEL ACT12: >12' x 7', 11 crates, >\$4M list

Donated Nov 2008 Prior to new lab completion

Vacuum sealed/stored at RFS. Thank you COE

Approved for sale March 2015

Repurchased by TEL via approved high bid process

# Picotrack PR Coat and Develop System Thank you TEL

### Sited in NanoLab April 2017



Fully automated coat R&D scale dual 6" and 8" coat and develop track.

Local support, consistent use of generic access pumps, motors, controllers

### PCT-200: ~8' x 4', 3 crates, >\$300K list

# Another view of the New Picotrack Coat and Develop Compliment to the DUV Stepper



### 3 DUV resists and back up i-line resist

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# Picotrack Retires 2 1990 Legacy SVG Tools Declining Reliability and Difficult to support



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## Recent Donation/Purchase from Toshiba 5 Evaps: 1<sup>st</sup> Contact 4/21/16... Delivered 5/23/16



3 old bell jars: good cryos Eguns/parts

2 recent box coaters









# Recent Donation from Toshiba Box coater with new e-gun dedicated for oxides Released May 4, 2017



2<sup>nd</sup> system being rebuilt as 3 target sputter chamber - 2018 Annual PI Meeting May 5, 2017

### **Academic Recharge Rates**

Fiscal Year	2016/17	2017/18	
Access Fee per month	\$91.20	\$89.00	- <b>2</b> %
General Laboratory Rate	<b>\$45.00/hr</b>	<b>\$43.20/hr</b>	- 4%
	Cap: \$1,400.00/month	Cap: \$1,400.00/month	
<b>Special Equip Rate Tier 1</b>	<b>Tier 1: \$21.00/hr</b>	<b>Tier 1: \$21.00/hr</b>	
wire bonder, HF vapor,	Tier 1 cap: \$200.00 / month	Tier 1 cap: \$200.00 / month	- 1%
polymer, metrology	Rate over Tier 1 Cap: \$0/hr	Rate over Tier 1 Cap: \$0/hr	
<b>Special Equip Rate Tier 2</b>	<b>Tier 2: \$44.40/hr</b>	<b>Tier 2: \$43.80/hr</b>	- 1%
LPCVD, PECVD, DRIE, general	Tier 2 cap: \$1,400.00/month	Tier 2 cap: \$1,400.00/month	
purpose SEM	Rate over Tier 2 cap: \$6.15/hour	Rate over Tier 2 cap: \$5.70/hour	- 7%
<b>Special Equip Rate Tier 3</b>	<i>Tier 3: \$63.60/hr</i>	<i>Tier 3: \$60.00/hr</i>	- 6%
DUV, 50kV ebeam litho	<i>Tier 3 cap</i> : \$1,500.00/month	<i>Tier 3 cap</i> : \$1,500.00/month	
SEM, epi-SiGe	<i>Rate over Tier 3 cap</i> : \$19.60/hour	<i>Rate over Tier 3 cap</i> : \$19.20/hour	- 2%
<b>Special Equip Rate Tier 4</b> 130 kV ebeam litho	NA	Tier 4: \$101.40	NA
Staff Services	\$84.00	\$84.60	+ 1%

### **BNLA Recharge Rates**

Fiscal Year	2016/17	2017/18		Academic
Access Fee per month	\$116.00	\$123.60	+ 7%	\$89
General Laboratory Rate	<b>\$49.20/hr</b> Cap: \$2,450.00/month	<b>\$47.40/hr</b> Cap: \$2,500.00/month	- 4% + 2%	43.20 \$1,400
<b>Special Equip Rate Tier 1</b> wire bonder, HF vapor, polymer, metrology	<b>Tier 1: \$21.00/hr</b> Tier 1 cap: NA	<b>Tier 1: \$21.00/hr</b> Tier 1 cap: NA		\$21.00 \$200
<b>Special Equip Rate Tier 2</b> LPCVD, PECVD, DRIE, general purpose SEM	<b>Tier 2: \$51.00/hr</b> Tier 2 cap: NA	<b>Tier 2: \$52.20/hr</b> Tier 2 cap: NA	+ 2% 	\$43.80 \$1,400
<b>Special Equip Rate Tier 3</b> DUV, 50kV ebeam litho SEM, epi-SiGe	<b>Tier 3: \$80.40/hr</b> Tier 3 cap: NA	<i>Tier 3: \$84.60/hr</i> <i>Tier 3 cap</i> : NA	+ 5% 	\$60.00 \$1,500
<b>Special Equip Rate Tier 4</b> 130 kV ebeam litho	NA	Tier 4: \$214.80	NA	\$101.40
Staff Services	\$84.00	\$84.60	+ 1%	\$84.60

## **BNLA Annual Membership Fees**

FY 16/17		FY 17/18		
Lab Members Per Company	Annual Rates	Lab Members Per Company	Annual Rates	
1	\$18,500	1	\$18,500	
2	\$28,500	2	\$28,500	
3	\$38,500	3	\$38,500	
4	\$42,500	4	\$42,500	
5	\$55,000	5	\$55,000	
6	Cancelled	6 **	\$65,000	

\*\* Non-Core Access Program

- 6<sup>th</sup> member = restricted access
- max 20hours/month 10am 8pm
- unlimited non-core 8pm 10am

## VCR Investment in the NanoLab

### ➢ FY15 \$250K

- NanoLab obtains \$650K Gift In Kind as match for 2year VCR Investment
- Purchased 2chamber PECVD and 2chamber PVD for \$300K
- ➢ FY16 \$250K
  - \$100K to new ebeam down payment
  - \$100K to new aligned wafer bonder

### FY17 \$100K; NanoLab to Match

- Investment to support AFM purchase; \$100K VCR / \$100K BNLA
- AFM review underway Bruker, Park, Nanosurf
- Tool selection to emphasize robust instrument to meet heavy use by wide range of NanoLab members

# Summary

- Academic Rates kept flat or decreased
  - Overall membership modest decrease
  - EECS, Physics, MSE Dept use steady
  - Mech Eng, Bio Eng, Chem Dept use decline
- Modest increases to BNLA
  - New non-core hour access program under test
- NanoLab continues to expand services and capabilities
  - On line video workshops for new member training
  - On line base line process specification and monitoring
  - 130kV ebeam
  - 6"/8" new PR coat and develop
  - New ebeam dedicated to oxides

VCR investment in NanoLab to support AFM purchase

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The shared lab model is alive and well thanks to your support.

The NanoLab responds to your issues and works to control your costs.



"The great thing about the Microlab is the way it evolves."

UC Berkeley EECS Professor, William G. Oldham



